

AMENDMENTS TO THE CLAIMS

1. (Currently Amended) An aluminum stabilization stacked body ~~(301)~~ formed by stacking a stabilization layer ~~(303)~~ formed with a metal and having a thickness of 0.001-1 μm with any of a sputtering method, a deposition method and an ion plating method on a whole surface of a thin film ~~(302)~~ having a surface formed with aluminum, and stacking a plated layer ~~(304)~~ on a surface of the stabilization layer ~~(303)~~.

2. (Currently Amended) The aluminum stabilization stacked body ~~(301)~~ according to claim 1, wherein

the thin film ~~(302)~~ having the surface formed with aluminum is aluminum foil rolled to have a thickness of 4-200 μm .

3. (Previously presented) The aluminum stabilization stacked body according to claim 1, wherein

the thin film having the surface formed with aluminum is formed by affixing a polymer film to aluminum foil.

4. (Currently Amended) The aluminum stabilization stacked body ~~(301)~~ according to claim 1, wherein

the metal is any of Cu, Ni, and an alloy including Cu and/or Ni.

5. (Canceled)